

ABSTRACT

METHOD FOR FABRICATING A FLUID EJECTION DEVICE

A method of fabricating a fluid ejection device 1 comprises providing a barrier layer 4 which defines fluidic spaces 43. The fluidic spaces 43 defined by the barrier layer 4 are filled with filler 44. A throughway 24 is etched through the substrate 2. The filler 44 is removed from the fluidic spaces 43 after etching the throughway 24.

(FIG. 1)